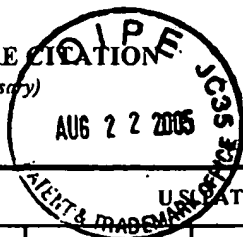


**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)



Docket Number (Optional)  
**YPL-0099**

Application Number  
**10/825,297**

Applicant(s)  
**Jae-ho YOU, et al.**

Filing Date  
**8-27-2004**

Group Art Unit  
**1645**

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
RTC		6,117,631	9-12-2000	Nilsen	435	6	10-29-1996
RTC		6,141,096	10-31-2000	Stern, et al.	356	318	3-25-1997

**U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		<del>2002/0124565 A1</del>	<del>9-12-2002</del>	<del>Cunningham, et al.</del>	<del>435</del>	<del>6</del>	<del>8-15-2001</del>

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

		<del>Office Action of KP 10-2003-0033979 mailed by Korean Intellectual Property Office on May 18, 2005</del>

EXAMINER /Robert Crow/

DATE CONSIDERED 08/30/2006

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.